

Can 3723

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of: Peter Wolters
Application No.: 09/523,115
Filed: March 10, 2000
For: DOUBLE DISK POLISHING MACHINE,
PARTICULARLY FOR TOOLING
SEMICONDUCTOR WAFERS
Examiner: (Not yet assigned)
Group Art Unit:

Assistant Commissioner for Patent
Washington, D.C. 20231

Docket No.: H01.2-8984

TRANSMITTAL LETTER

1. In regard to the above-identified application, we are submitting the attached:
Transmittal of 2 priority documents

2. With respect to fees:

- ☒ No additional fee is required.
☐ Attached is check(s) in the amount of \$00
☐ Charge additional fee to our Deposit Account No. 22-0350.

3. **CONDITIONAL PETITION FOR EXTENSION OF TIME**

This conditional petition is being filed along with the papers identified in Item 1 above and provides for the possibility that Applicant has inadvertently overlooked the need for a petition and fee for extension of time or for a petition and fee for any other matter petitionable to the Commissioner as required. If any extension of time for the accompanying response is required or if a petition for any other matter is required, by petitioner, Applicant requests that this be considered a petition therefor.

4. Notwithstanding paragraph 2 above, if any additional fees associated with this communication are required and have not otherwise been paid, including any fee associated with the Conditional Petition for Extension of Time, or any request in the accompanying papers for action which requires a fee as a petition to the Commissioner, please charge the additional fees to Deposit Account No. 22-0350. Please charge any additional fees or credit overpayment associated with this communication to the Deposit Account No. 22-0350.

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VIDAS, ARRETT & STEINKRAUS

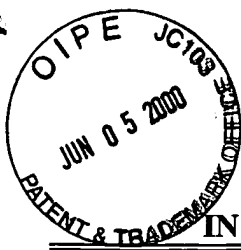
By

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Certificate Under 37 CFR 1.8: I hereby certify that this Transmittal Letter and the paper(s) as described herein, are being deposited in the U.S. Postal Service, as FIRST CLASS MAIL, addressed to BOX , Commissioner of Patents and Trademarks, Washington D.C. 20231, on May 31, 2000

Julie Emerson



PATENT

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TRANSMITTAL OF PRIORITY DOCUMENTS

Enclosed for filing please find certified copies of the priority documents, i.e.,
German Appln 199 11 313.0 and 100 07 390.5

Respectfully submitted,

VIDAS ARRETT & STEINKRAUS


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Date: MAY 31, 2000